Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	4103	semiconductor and (gate adj stack)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/18 15:41
L2	3651	1 and (remov$4 or etch$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/18 15:41
L3	2422	2 and spacer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/18 15:41
L4	1886	3 and implant$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/18 15:41